



UNIA EUROPEJSKA
EUROPEJSKI FUNDUSZ
ROZWOJU REGIONALNEGO



Nowy system do epitaksji z wiązek molekularnych i charakteryzacji *in-situ* otrzymywanych nanostruktur

Lech Tomasz Baczewski

ON 3.4



INNOVATIVE ECONOMY
NATIONAL COHESION STRATEGY



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European Union Operational Program for Innovative Economy 2007-2013

National Centre: Magnetic Nanostructures for Spintronics Applications **SPINLAB**

Total amount: 10 mln Euros

Participants: Members of National Scientific Network ARTMAG
, „Magnetic Nanostructures for Spintronics”

Institute of Molecular Physics PAS, Poznan, Poland

Institute of Physics PAS, Warsaw, Poland

University of Bialystok, Bialystok, Poland

University of A. Mickiewicz, Poznan, Poland

University of Science and Technology, AGH, Krakow, Poland

Institute of Catalysis and Surface Physico-chemistry PAS, Krakow, Poland



INNOVATIVE ECONOMY
NATIONAL COHESION STRATEGY



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Project goal:

**Development of scientific infrastructure in the laboratories
studying magnetic nanostructures, nanotechnology and
nanoelectronics in Poland**

Project coordination:

Coordinator: Prof. F. Stobiecki, IFM PAN, Poznan

Partners coordinators:

Prof. L. T. Baczewski - IF PAN Warsaw <http://spinlab.ifpan.edu.pl>

Prof. T. Stobiecki - AGH WE Krakow

Prof. A. Maziewski - UwB WF Białystok

Prof. J. Barnas - UAM WF Poznań

Prof. J. Korecki - IKiFP PAN Krakow

Scientific equipment to be purchased in the frame of *SPINLAB* project:

IF PAN Warsaw: new MBE system with in situ MOKE, ion gun and VT SPM microscope, He-3 cooler (50 mK) for PPMS, and also EDX together with cathodoluminescence (CL) and nanopatterning option for SEM Zeiss microscope

IFM PAN Poznan: Magnetron sputtering, IBS and PLD system for thin films deposition

AGH Krakow: equipment for dynamical time resolved magnetoresistance measurements and computer cluster for simulations, RT AFM/MFM

IKiFP PAN Krakow: LEEM-PEEM (PhotoEmission Electron Microscope – Low Energy Electron Microscope, resolution 8 nm) together with a deposition chamber for adaptation at synchrotron beamline

UAM Poznan: powerful computer cluster for modelling and simulations

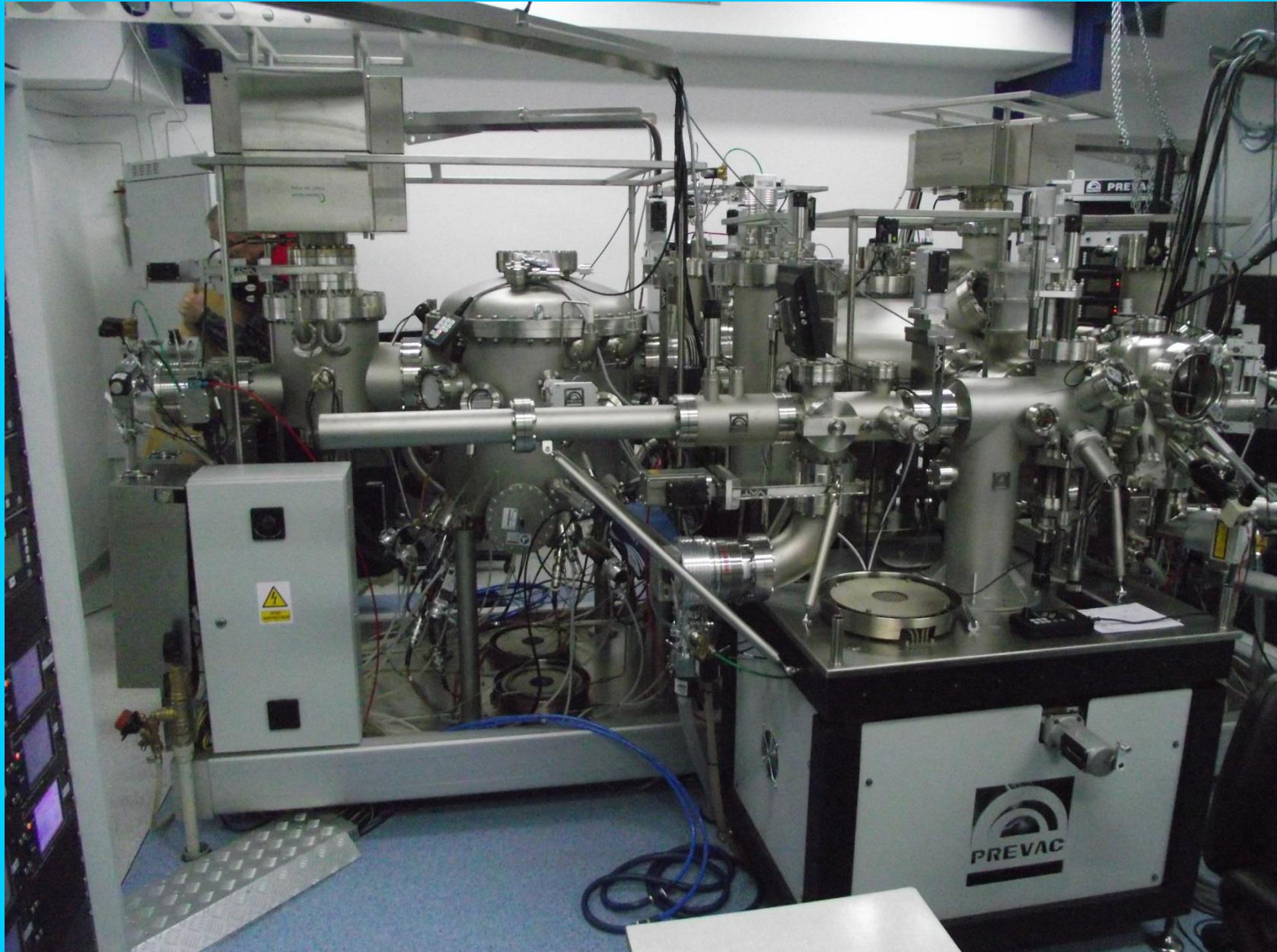
University of Bialystok: BLS spectrometer, femtosecond lasers for magneto-optical measurements, optical cryostat with superconducting coils for high magnetic fields up to 8T

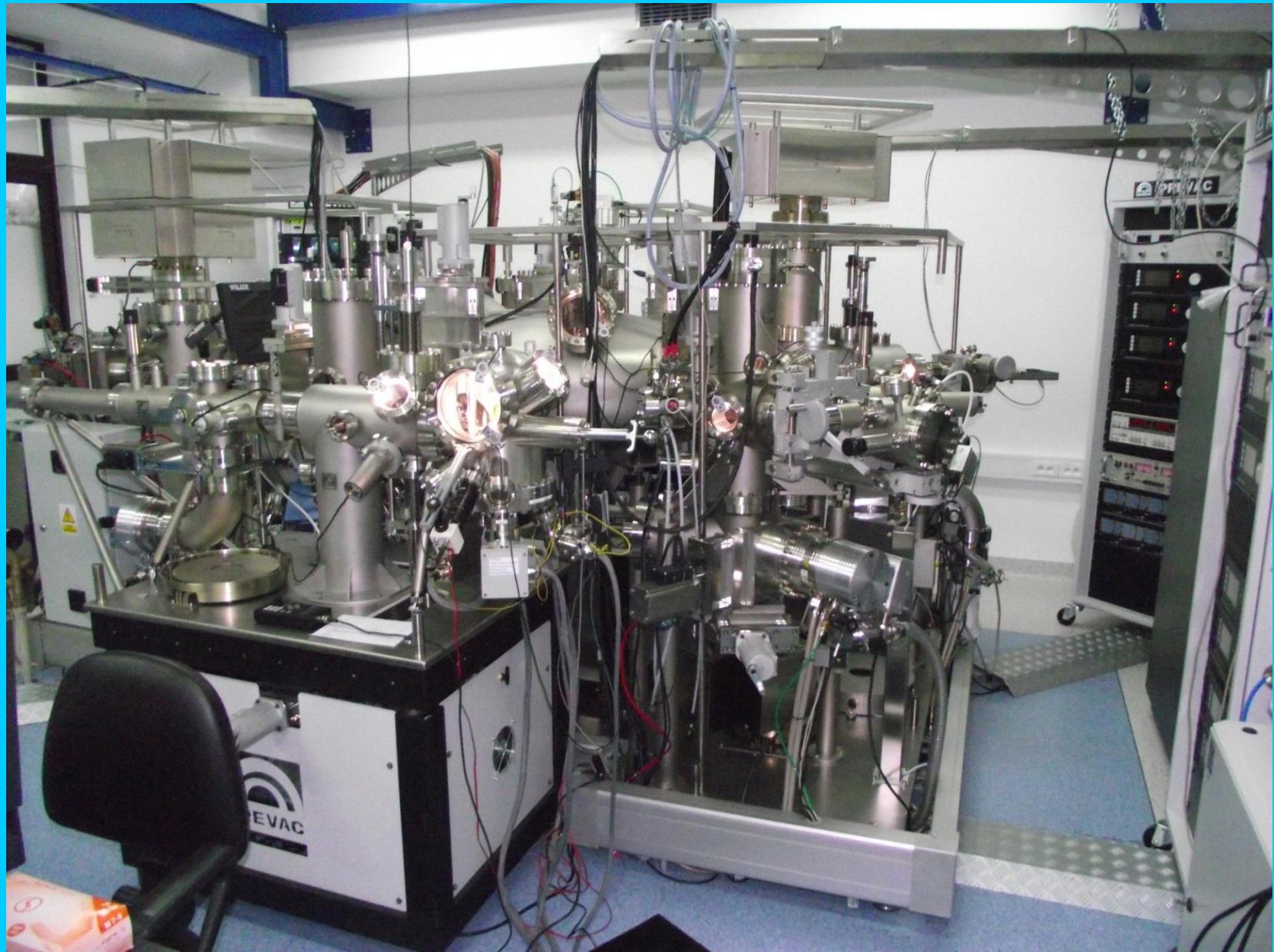


Multi-chamber Prevac MBE system configuration :

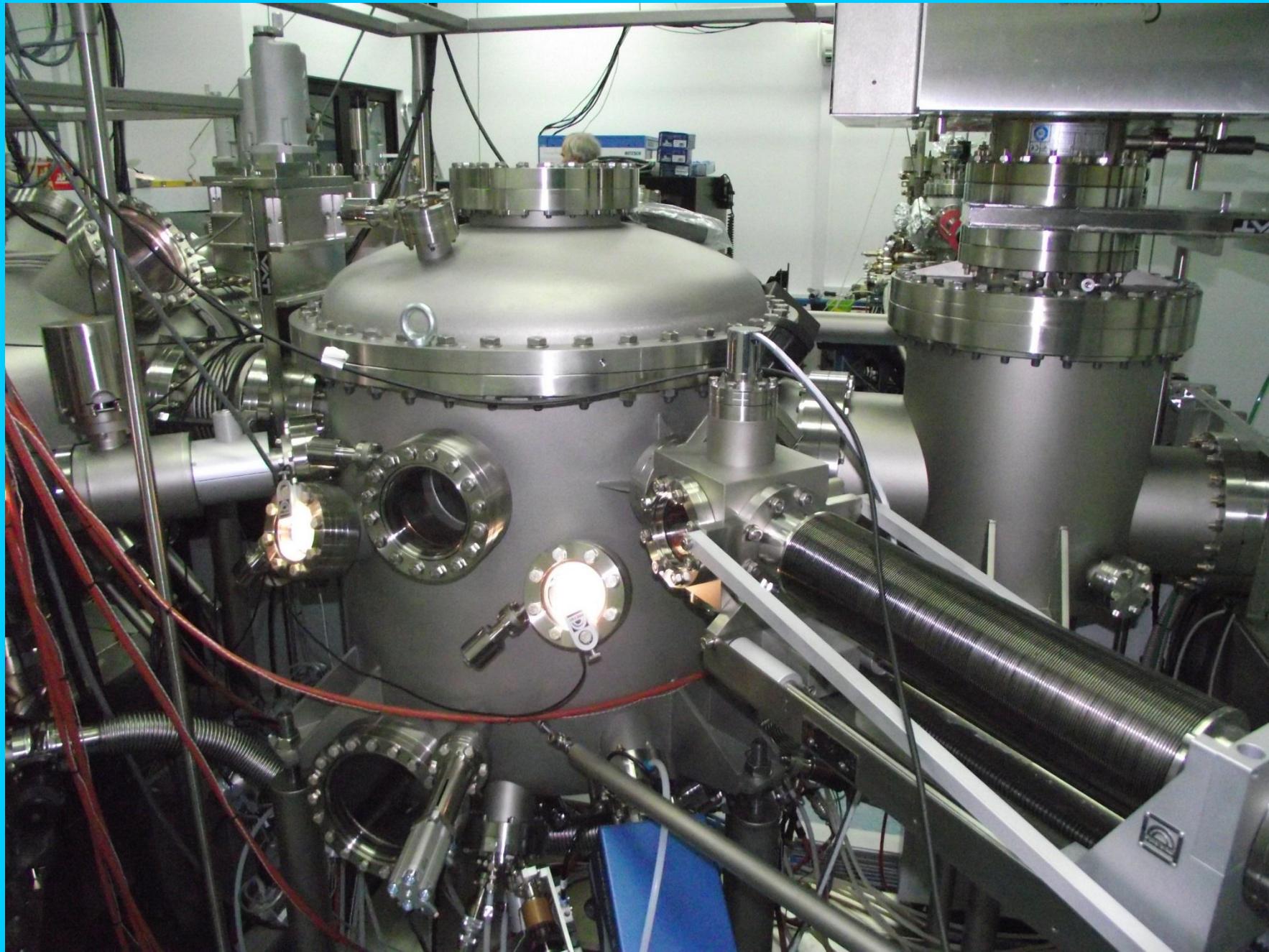
- Growth chamber (1)
- Load-lock chamber (2)
- Preparation chamber (3)
- Ion source 30 keV chamber (4)
- Storage chamber (5)
- Magnetooptical characterization (MOKE) chamber (6)
- Scanning probe microscope SPM chamber (7)
(Omicron microscope VT AFM/STM XA 50/500)
- Reorientation chamber - connected to SPM (8)
- SPM probes loading chamber (9)
- Distribution chamber (10)

Multi-chamber MBE system from PREVAC





Deposition Chamber





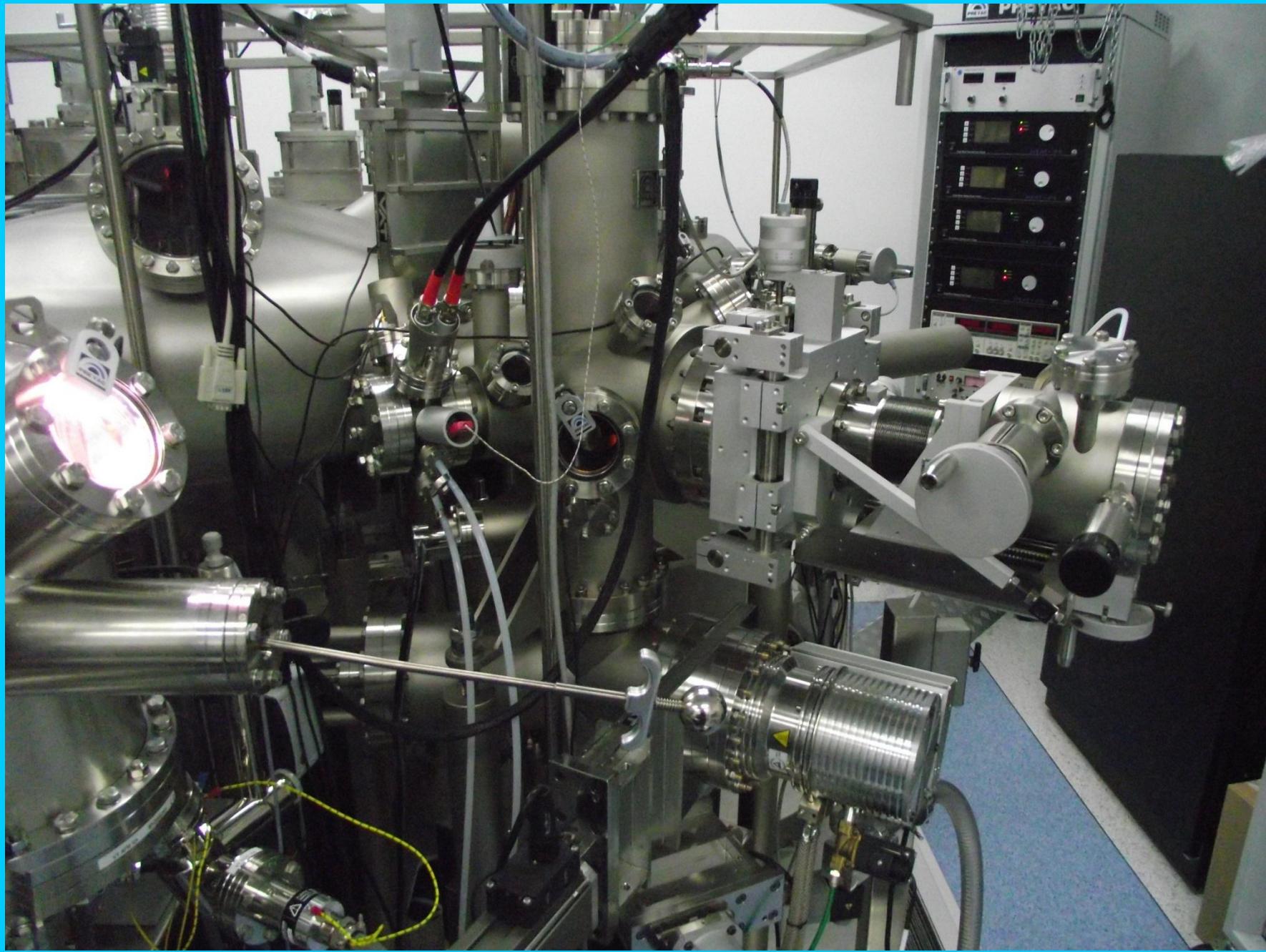
Growth chamber equipment:

- Vacuum < 5 x10⁻¹¹ Torr
- 3 inches moliblock heating up to 1400 C by electron bomardement
- Two electron guns Telemark 10kV, 6 targets each
- Eight effusion cells:
 - 6 high temperature cells up to 1700 C
 - 2 dual filament cells up to 1400 C
- Movable shutter controlled by step motor for wedge structures
- Movable Quartz oscillator
- Two MKS mass spectrometers for flux control of e-guns down to 0.001 nm/s
- RHEED - STAIB 20 kV
- Color CCD camera for moliblock observation – computer controlled
- Heitronics pirometer for temperature control on a moliblock surface in the range 200 – 1700 deg C
- Software controlling all technological processes

Distribution Chamber (UFO)



Preparation chamber

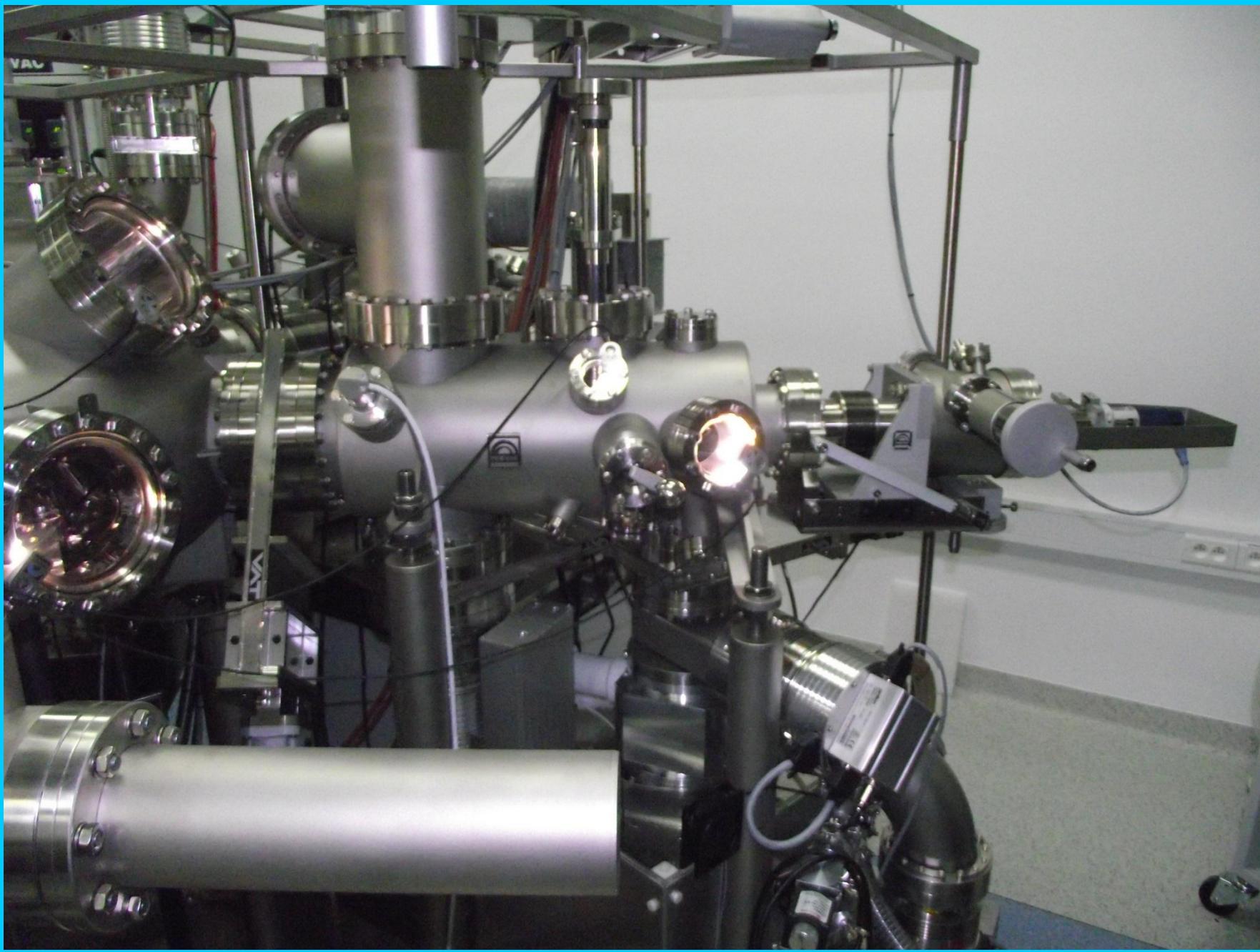




Preparation chamber

- Annealing of samples and substrates on SPM holders by electron bombardement up to 1700 C
- Annealing station of samples and semiconductor substrates by direct heating of electric current on special holders provided by Omicron
- Manipulator for transport of SPM holders between moliblocks and annealing stations
- LEED and Auger spectrometer AES (with LaB₆ cathode) allowing to measure every point on a 3 inches moliblock
- (with adequate software)

Ion gun chamber





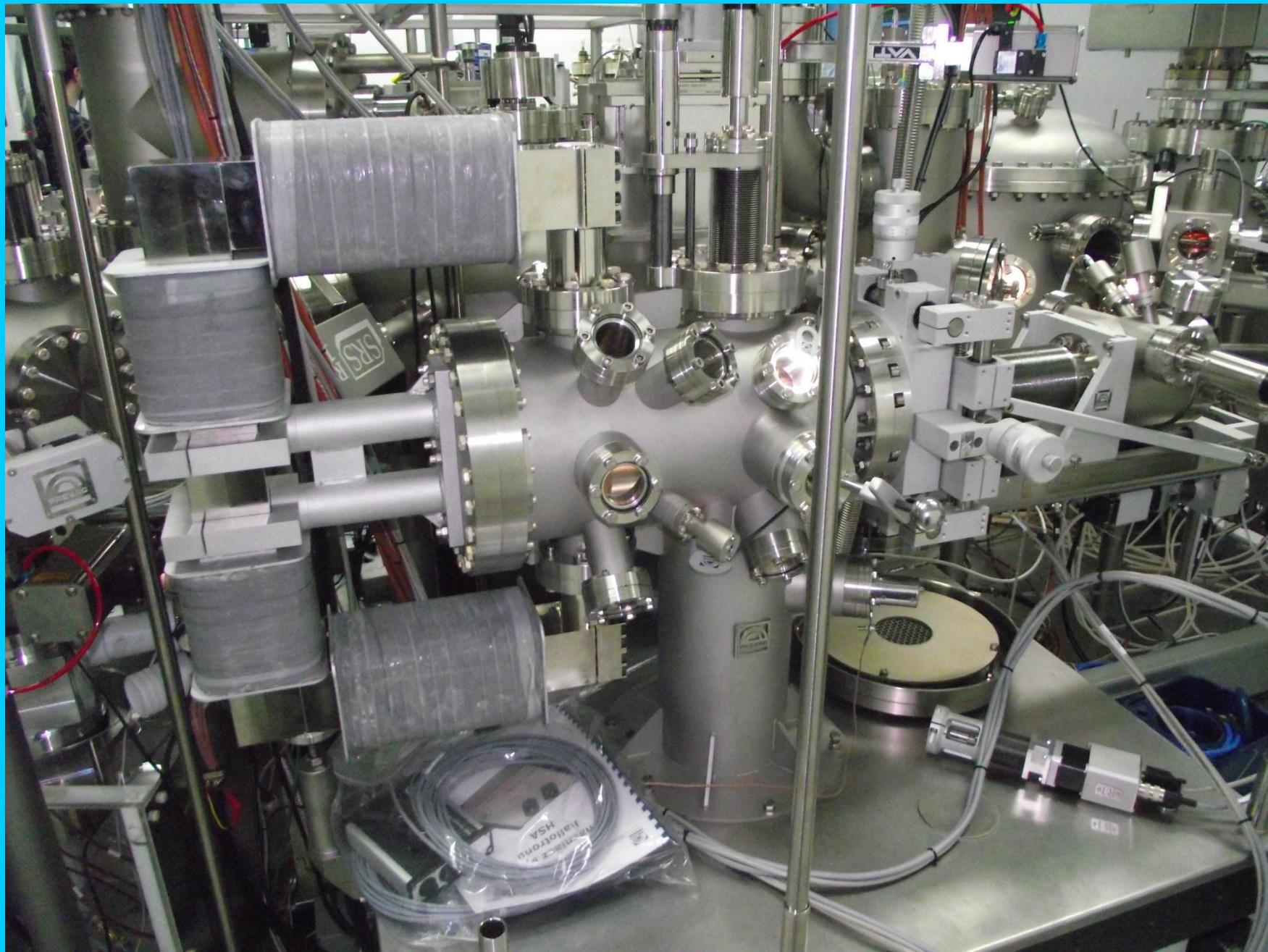
Ion gun chamber

- Ion gun for noble gases (Ar and He) - Peabody Scientific
- with regulated ions energy from 2 to 30 keV,
- uniform energy distribution on 10x10 mm² substrate,
- doses regulation,
- water cooling system
- Movable shutter
- Manipulator allowing to change the angle between the ion beam and a substrate plane in the range 0 -90 deg
- Differential pumping facility with two independent turbo pumps

Storage chamber

- Connected to the distribution chamber with gate valve
- Turbo and ion pumps – 10⁻¹¹ Torr
- Six position stage for moliblocks storage

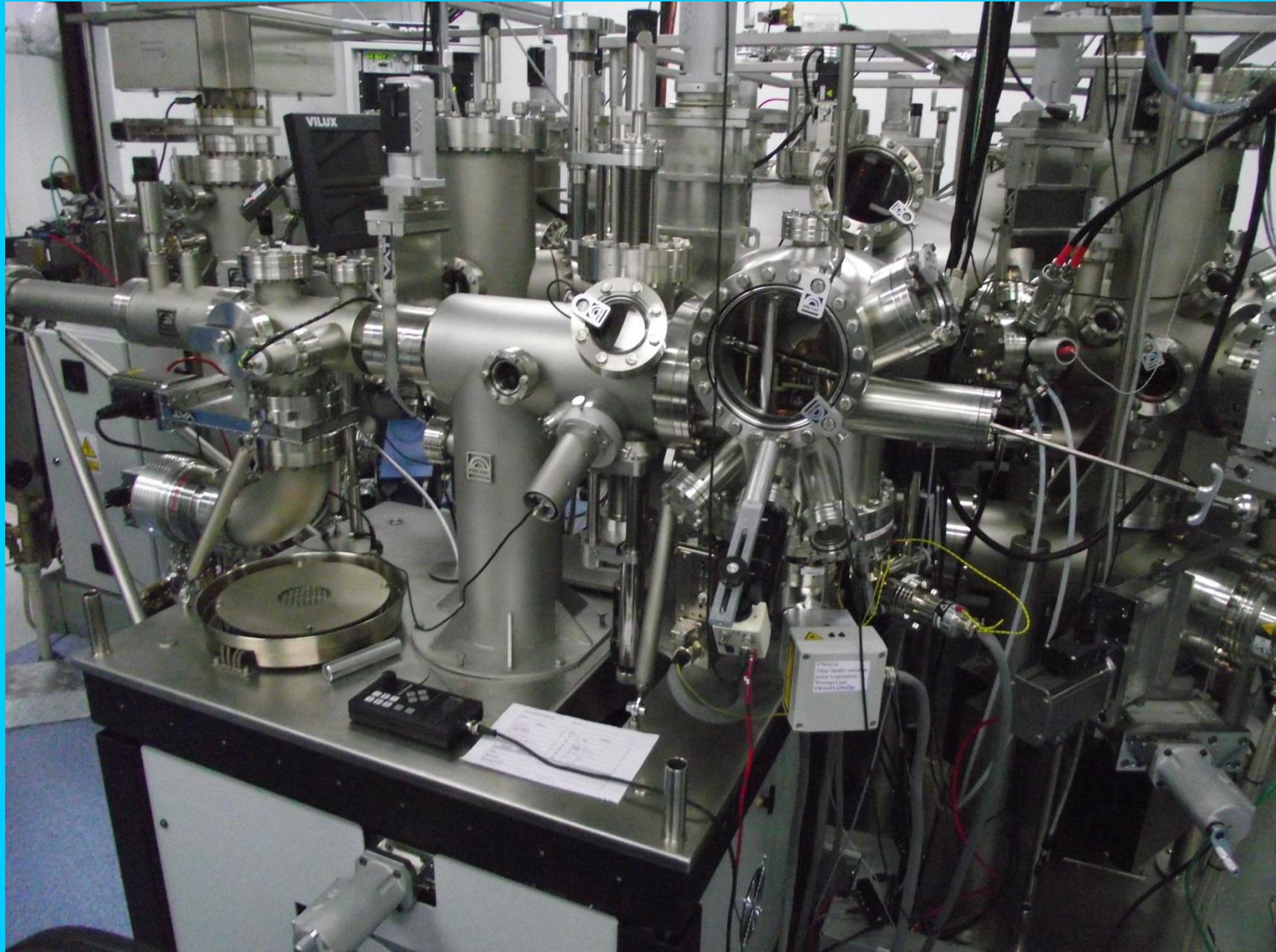
Magneto-optical characterization chamber



Magneto-optical characterization chamber

- Electromagnet providing magnetic field of +/- 0.1 Tesla
- Possibility of MOKE measurements in polar and longitudinal configurations given by a special rotating manipulator
- Bi-polar power supply KEPCO for inductance load
- Step motor controlled manipulator for sample positioning with precision 10 microns and rotation with resolution 0.1 deg for in-plane anisotropy measurements
- Manipulator with wobble stick to handle SPM holders
- Two optical lines for detection of polar and longitudinal Kerr effects
- Laser of 640 nm wave length, regulated power of 30mW, PEM modulator, Glan-Thompson polarizer, Glan-Tyler analizer, photodetectors, beam splitters, lock-in amplifier
- CCD color camera for observations of sample and laser spot
- Hallotrons for measuring the amplitude of magnetic field
- Ion pump of 600l/s, vacuum 10^{-11} Torr
- Software for data acquisition
- Anti-vibrational pneumatic system

Reorientation and SPM chamber





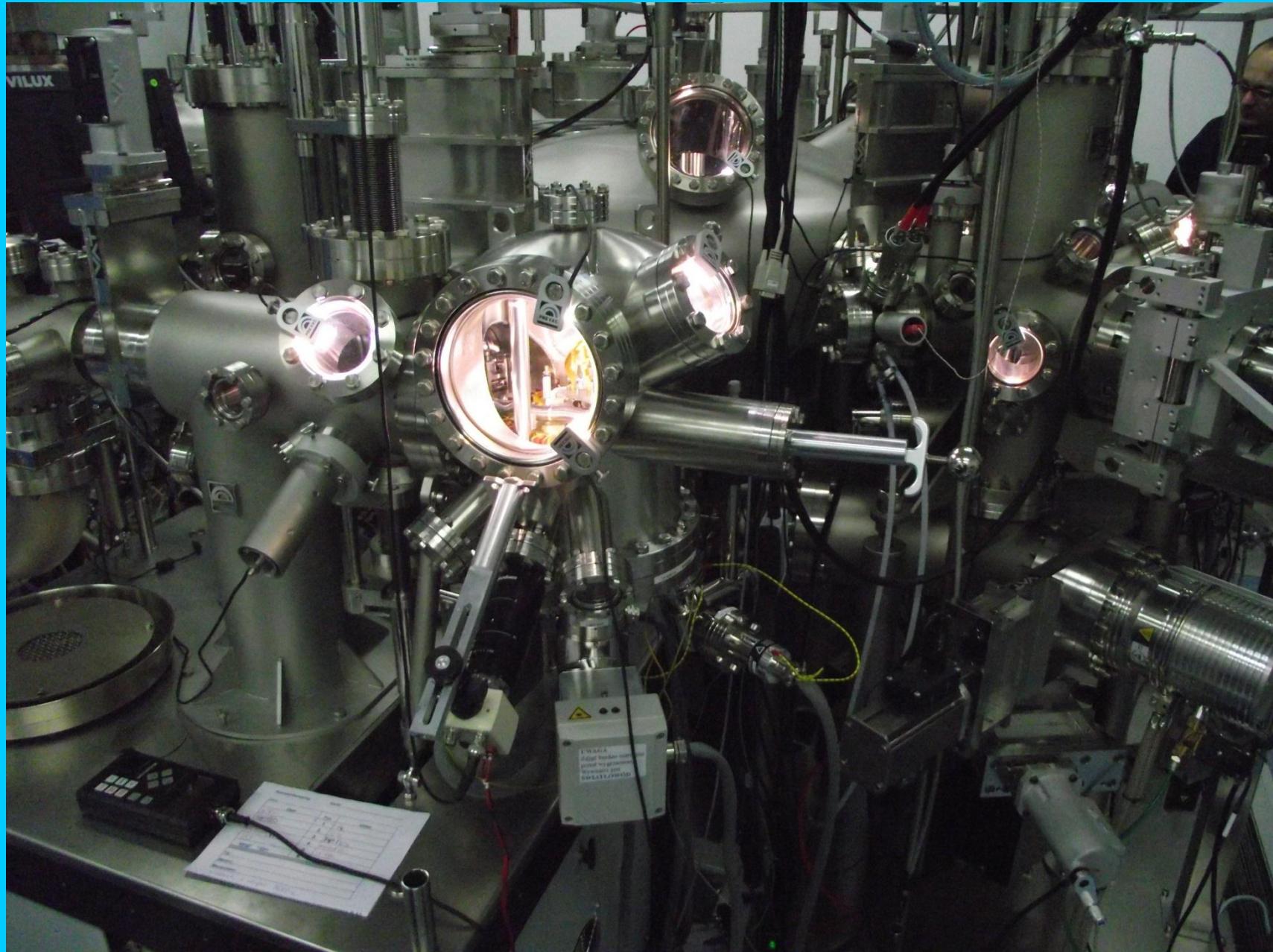
Reorientation chamber

- Attached to the distribution chamber UFO – for transportation of SPM holders from moliblock to the transfer system of SPM
- Connected to the SPM Omicron chamber
- Manipulator and transfer system to microscope holder station

SPM probes loading chamber

- Designed for quick loading of SPM probes (and samples) directly into the SPM microscope without necessity to transport them through a whole MBE system
- Electron bombardement heating of SPM probes facility up to 150 C
- Docking station for 3 probes

Omicron SPM VT 50/500 model



SPM Omicron VT 50/500 model

- Microscope working in:
 - contact mode AFM-CM
 - non-contact mode AFM-NCM
- Magnetic force microscopy MFM
- Electrostatic force microscopy EFM in non-contact mode
- Scanning Tunneling Microscopy STM (constant height and constant current modes)
- Tunneling spectroscopy STS - CITS, $I(V)$, $I(Z)$, $I(V,Z)$, dI/dV , d^2I/dV^2
- Laser beam detection of cantilever deflection
- AFM signal detection:
 - cantilever deflection,
 - oscillation amplitude,
 - phase and/or oscillation frequency
- Scan size 10x10 microns
- STM/STS – atomic resolution, tunneling current detection in the range of 1 pA – 200 nA
- I/V characteristics in the voltage range +/- 10 V

2010 – W ramach projektu **Krajowe Centrum Nanostruktur Magnetycznych do Zastosowań w Elektronice Spinowej – SPINLAB** mikroskop ZEISS Auriga (Neon 40) został doposażony o rentgenowski spektrometr energii EDX oraz o system katodoluminescencji.

W ramach **SPINLAB-u** zakupiono:

- **SEM EVO HD 15** firmy Zeiss,
- **Układ do pomiaru katodoluminescencji** firmy Horiba,
- **Kriostat niskotemperaturowy** firmy K&W,
- **Stolik Peltier** firmy Deben,
- **Rentgenowski spektrometr energii EDX** firmy Bruker,
- Oprogramowanie **Nanopatterning Engine** do cyfrowej kontroli działa jonowego FIB

SEM EVO CL Zeiss



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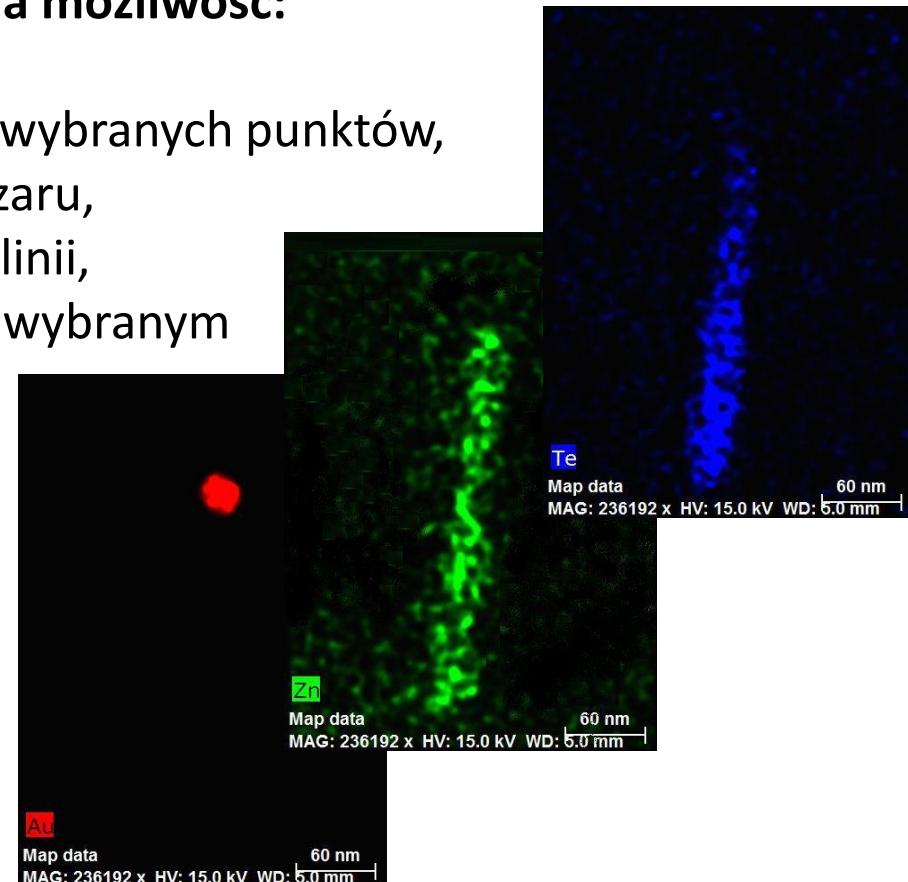


Widma CL (CCD, PMT mono) od RT do LHe
Mapy CL (CCD, PMT poli) od RT do LHe

System do Mikroanalizy Rentgenowskiej EDX firmy Bruker

Spektrometr EDX zapewnia możliwość:

- analizy punktowej,
- analizy z wielu wstępnie wybranych punktów,
- analizy z wybranego obszaru,
- analizy wzdłuż dowolnej linii,
- rozkład pierwiastków na wybranym obszarze - mapowanie,
- analizy fazowej.



Mapy rozkładu pierwiastków nanodrutu ZnTe.

Kriostat - niskie temperatury (4.2 K do 300 K)

Montaż próbek



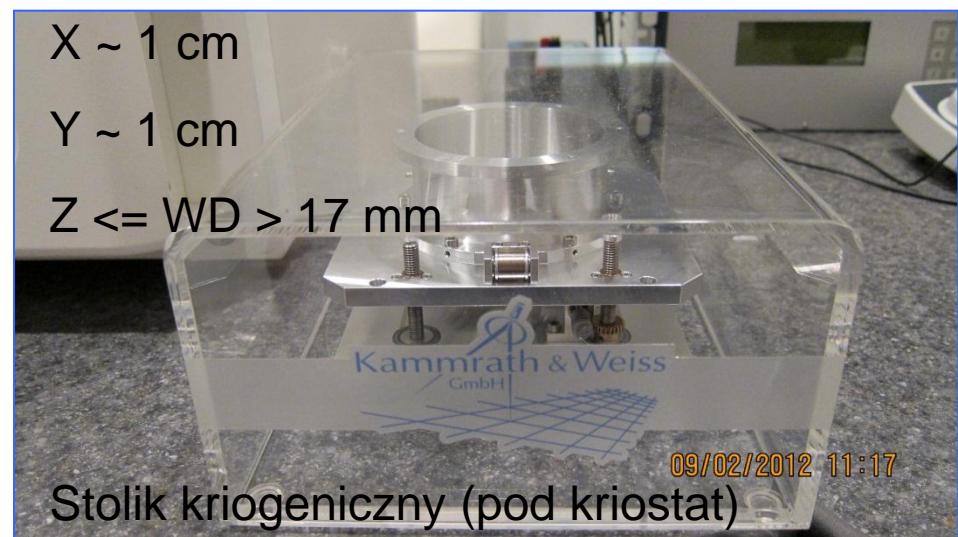
- bezpośrednio na uchwyt
- na stolik mikroskopowy

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X ~ 1 cm

Y ~ 1 cm

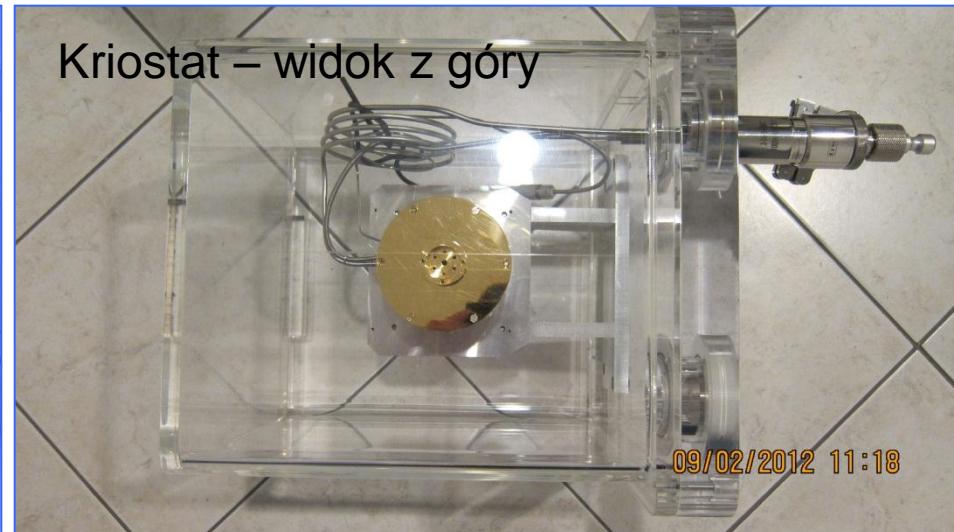
Z <= WD > 17 mm



Kriostat – widok z przodu



Kriostat – widok z góry



He-3 dilution refrigerator (temperature down to 50 mK) for PPMS

